## Application/Control No. Applicant(s)/Patent Under Reexamination 10/664,931 CHAE ET AL. Notice of References Cited Examiner Art Unit Page 1 of 1 2871 Richard H. Kim **U.S. PATENT DOCUMENTS Document Number** Date Name Classification Country Code-Number-Kind Code MM-YYYY US-5,349,205 09-1994 Kobayashi et al. 257/59 Α US-В US-С US-D US-Ε US-F US-G US-Н US-US-J US-K US-US-М FOREIGN PATENT DOCUMENTS **Document Number** Date Country Name Country Code-Number-Kind Code Classification MM-YYYY Ν 0 Р Q R S T

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